# Surface Micromachined Arrays of Transition-Edge Detectors, Phase I



Completed Technology Project (2004 - 2004)

### **Project Introduction**

An innovative surface micromachining technique is described for the fabrication of closely-packed arrays of transition edge sensor (TES) x-ray microcalorimeters. This technique enables individual TES microcalorimeters to be suspended on a thin membrane for thermal isolation from the bath temperature. The TES detectors are fabricated from normal metal/superconductor bilayers with a transition temperature of around 0.1 K. The proposed surface micromachining technique will simplify the fabrication of closely-packed TES microcalorimeter arrays, which are needed for numerous applications in astronomical x-ray spectroscopy.

### **Primary U.S. Work Locations and Key Partners**



Organizations Performing Work	Role	Туре	Location
☆Goddard Space Flight Center(GSFC)	Lead	NASA	Greenbelt,
	Organization	Center	Maryland
STAR Cryoelectronics,	Supporting	Industry	Santa Fe,
LLC	Organization		New Mexico

Primary U.S. Work Locations	
Maryland	New Mexico



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# Organizational Responsibility

# Responsible Mission Directorate:

Space Technology Mission Directorate (STMD)

#### **Lead Center / Facility:**

Goddard Space Flight Center (GSFC)

#### **Responsible Program:**

Small Business Innovation Research/Small Business Tech Transfer



### Small Business Innovation Research/Small Business Tech Transfer

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## **Project Management**

**Program Director:** 

Jason L Kessler

**Program Manager:** 

Carlos Torrez

**Principal Investigator:** 

Robin H Cantor

# **Technology Areas**

### **Primary:**

- TX08 Sensors and Instruments
  - ☐ TX08.1 Remote Sensing Instruments/Sensors
    - ☐ TX08.1.1 Detectors and Focal Planes

